

EAST Search History**EAST Search History (Prior Art)**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	100411	MEMS microelectromechanical micro-electro-mechanical (micro adj electro adj mechanical) micromechanical micro-mechanical (micro adj mechanical)	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:28
L2	155173	(fixed stationary) adj2 (plate\$1 board\$1 substrate\$1 wafer\$1)	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:29
L3	283265	(signal near3 modulat\$3)	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:29
L4	7050170	time\$1 timing	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:29
L5	3403040	(gap opening\$1)	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:29
L6	907	((electrostatic\$5 electro-static\$5) with ((moving movable moveable) adj2 (plate\$1 substrate\$1 board\$1 wafer\$1))	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:31
L7	981359	(circuit\$2 near3 control\$5)	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:31
L8	768	1 same 2	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:31
L9	1	3 same 8	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:32
L10	1	4 same 9	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:32
L11	4562	1 and 2	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:32

L12	340	3 and 11	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:32
L13	323	4 and 12	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:32
L14	219	5 and 13	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:32
L15	16	6 and 14	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:32
L16	13	7 and 15	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:32
L17	12	16 not 9	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:32
L18	1831589	voltage\$1	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:35
L19	12	17 and 18	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:35
L20	0	19 not 17	US- PGPUB; USPAT; EPO; JPO	OR	ON	2009/11/07 18:35

EAST Search History (Interference)

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11/7/09 6:57:24 PM**C:\Documents and Settings\bthomas1\My Documents\EAST\Workspaces\10782593_update6.wsp**